



Class	Subclass	Issue Classification

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

APPLICATION NO. 09/839763	CONT/PRIOR D	CLASS 156	SUBCLASS 215	ART UNIT 1763	EXAMINER Hassanzadeh
------------------------------	-----------------	--------------	-----------------	------------------	-------------------------

Kyle Lebouitz
Michale Migliuolo

Apparatus for etching semiconductor samples and a source for providing a gas by sublimation thereto

PTO-2040
12/99

ISSUING CLASSIFICATION

Continued on Issue Slip Inside File Jacket

WARNING:

¹¹¹ information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.

Form PTO-438A
(Rev. 6/99)

FILED WITH: DISK (CRF) FICHE CD-ROM
(Attached in pocket on right inside flap)